

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q85281

Yuji EGUCHI, et al.

Appln. No.: 10/518,013

Group Art Unit: 1792

Confirmation No.: 1952

Examiner: Binh X. Tran

Filed: December 14, 2004

For: OXIDE FILM FORMING METHOD AND OXIDE FILM FORMING APPARATUS

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

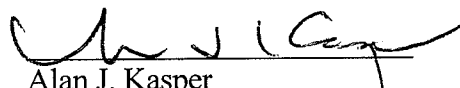
Sir:

Pursuant to 37 C.F.R. § 1.136, Applicants hereby petition for an extension of time of one month, extending the time for responding to the Office Action of October 23, 2009 from January 23, 2010 to February 23, 2010.

The USPTO is directed and authorized to charge the statutory fee of \$130.00 and all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880.

Please also credit any overpayments to said Deposit Account.

Respectfully submitted,



Alan J. Kasper  
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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: February 23, 2010